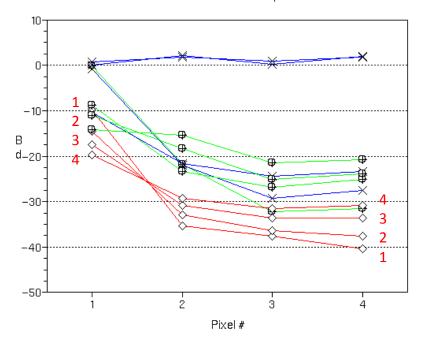


### Wafers

Segmented guard rings
New Hamamatsu sensors
Test bench

## R&D on segmented guard rings crosstalk

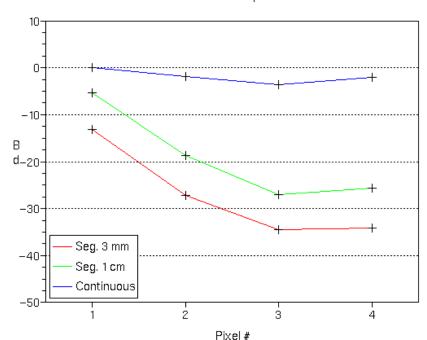
Crosstalk measurements vs pixel number



Sum of GRs contribution Xtalk lowered by a factor 80 (with 3 mm segments One lot (no statistics)

Far from the injection point, the injection through the outter GR is dominant

Total crosstalk vs pixel number



# R&D on segmented guard rings crosstalk

Interpretation: distributed capacitance due to the couplings between GR segments,

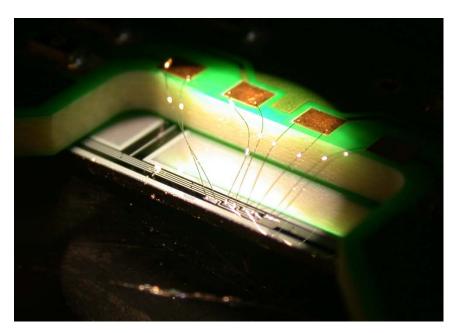
to be modeled?

More statistics needed

- Test bench at LPC (Clermont)
- •Time for meas.(2h< / sensors)

bounding attempt (CERN)
But add some Xtalk

S1			
	128	29	28
G1 800mV	572	28	30
	59	30	30
\$1			
	64	67	69
G4 800mV	156	69	68
	216	90	70



## R&D on segmented guard rings Electrical characteristics

Breakdown >250V

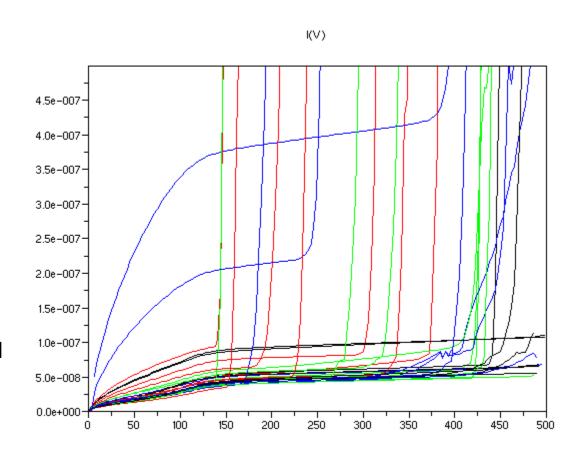
Continuous: 100%

•1 cm: 85%

•3 mm: 40%

•Mixed: 70%

T and RH impact to be studied



## R&D on segmented guard rings Next test matrices

Inter segment gap:

1 cm segment with 5, 10, 25 (actual: 50 um)

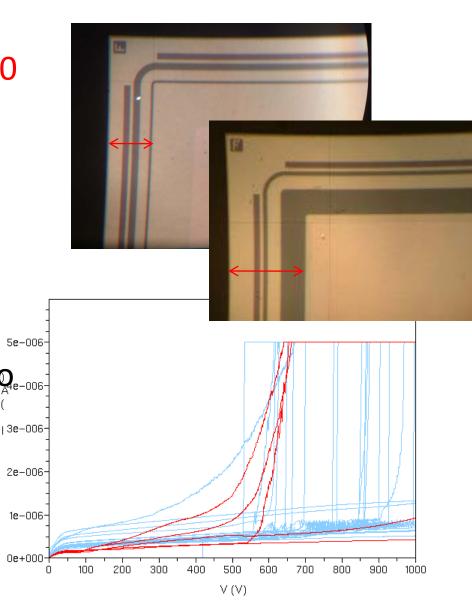
Distrubuter capacitance:

Mixed: inner 2cm, 1 cm, outter 3mm, 1mm

Similar sensors from BhaBha (Anita Topkar) Back from foundry by the end of June Tests at LPC & LLR cost!

New Hamamatsu sensor

- Dead area decreased to 750 um (1200 um previous)
- Leakage current issue seen at Hamamatsu
  - Level: x 5-10 wrt previous sensors
  - Non uniformity
- 5 samples
- Breakdown ok but seems to be slightly lower
- Overall current is better!
  - Full matrix is biased



#### Test bench

- Crosstalk:
  - New instrumentation board
  - New support
  - Mechanics
- I-V, C-V
  - T and RH dependency (by hands or with another lab?)
  - Automation: Switch board (4k€ up to 6 k€)
- LPC?

### Conclusion

- COST (~10€/cm², explected to be 2€/cm² for ILC)
  - Orders according to money...
  - Can have 40 wafers from Hamamatsu = 10 ASUs
  - Equipment of ASU with wafers have to be optimized
- Dead space at the edge can be lowered
- Guard-Ring R&D program Conference: IEEE sensors 09, Accepted!